



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

: Response Under 37 CFR 1.116 - Expedited Procedure

: Customer Number: 53080

Satoshi SHIBATA

: Confirmation Number: 2300

Application No.: 10/557,746

: Group Art Unit: 2813

Filed: November 21, 2005

: Examiner: Crawford, Latanya N

For: MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.



No additional fee is required.



Applicant is entitled to small entity status under 37 CFR 1.27



Also attached:

The fee has been calculated as shown below:

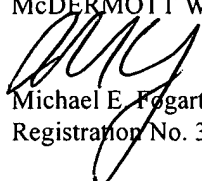
	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	12	20	0	\$50.00 =	\$0.00
Independent Claims	3	4	0	\$210.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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 Date: February 28, 2008

Please recognize our Customer No. 53080 as our  
 correspondence address.



Docket No.: 071971-0432

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Satoshi SHIBATA

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE

Application No.: 10/557,746

Filed: November 21, 2005

Customer No.: 53080  
Confirmation No.: 2300

Group Art Unit: 2813

Examiner: Crawford, Latanya N

Title: MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE

**AMENDMENT UNDER 37 CFR 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated November 28, 2007, having a three-month shortened statutory period for response set to expire February 28, 2008, please amend the above-identified application as follows.